Enter the docket number excluding the last three digits in the docket number field to access the document. At this time, the Commission has suspended access to the Commission's Public Reference Room, due to the proclamation declaring a National Emergency concerning the Novel Coronavirus Disease (COVID-19), issued by the President on March 13, 2020. For assistance, contact the Federal Energy Regulatory Commission at FERCOnlineSupport@ferc.gov or call toll-free, (886) 208-3676 or TYY, (202) 502-8659.

Dated: May 9, 2022.

Debbie-Anne A. Reese,

Deputy Secretary.

[FR Doc. 2022-10347 Filed 5-12-22; 8:45 am]

BILLING CODE 6717-01-P

DEPARTMENT OF ENERGY

Federal Energy Regulatory Commission

[Project No. 7569-008]

University of Notre Dame, ND Hydro, LLC; Notice of Transfer of Exemption

- 1. On April 21, 2022, University of Notre Dame, exemptee for the 2.5 Megawatts South Bend Hydroelectric Project No. 7569, filed a letter notifying the Commission that the project was transferred from University of Notre Dame to ND Hydro, LLC. The exemption from licensing was originally issued on April 18, 1984. The project is located on the St. Joseph River, St Joseph County, Indiana. The transfer of an exemption does not require Commission approval.
- 2. ND Hydro, LLC is now the exemptee of the South Bend Hydroelectric Project No. 7569. All correspondence must be forwarded to Paul Kempf, ND Hydro, LLC, 100 Facilities Building, Notre Dame, IN 46556, Phone: 574-631-6594 (main), 574-631-0142 (direct), and 574-631-8468 (fax), Email: Paul.A.Kempf.2@ nd.edu.

Dated: May 9, 2022.

Kimberly D. Bose,

Secretary.

[FR Doc. 2022-10358 Filed 5-12-22: 8:45 am]

BILLING CODE 6717-01-P

ENVIRONMENTAL PROTECTION AGENCY

[EPA-HQ-OAR-2021-0105; FRL-9863-01-OMS1

Information Collection Request Submitted to OMB for Review and Approval; Comment Request; NESHAP for Semiconductor Manufacturing (Renewal)

AGENCY: Environmental Protection Agency (EPA).

ACTION: Notice.

SUMMARY: The Environmental Protection Agency (EPA) has submitted an information collection request (ICR), NESHAP for Semiconductor Manufacturing (EPA ICR Number 2042.08, OMB Control Number 2060-0519), to the Office of Management and Budget (OMB) for review and approval in accordance with the Paperwork Reduction Act. This is a proposed extension of the ICR, which is currently approved through May 31, 2022. Public comments were previously requested, via the Federal Register (86 FR 19256), on April 13, 2021 during a 60-day comment period. This notice allows for an additional 30 days for public comments. A fuller description of the ICR is given below, including its estimated burden and cost to the public. An agency may neither conduct nor sponsor, and a person is not required to respond to, a collection of information unless it displays a currently valid OMB control number.

DATES: Additional comments may be submitted on or before June 13, 2022.

ADDRESSES: Submit your comments. referencing Docket ID Number EPA-HQ-OAR-2021-0105, online using https://www.regulations.gov/ (our preferred method), by email to docket.oeca@epa.gov, or by mail to: EPA Docket Center, Environmental Protection Agency, Mail Code 28221T, 1200 Pennsylvania Ave. NW, Washington, DC 20460. EPA's policy is that all comments received will be included in the public docket without change including any personal information provided, unless the comment includes profanity, threats, information claimed to be Confidential Business Information (CBI), or other information whose disclosure is restricted by statute.

Submit written comments and recommendations to OMB for the proposed information collection within 30 days of publication of this notice to www.reginfo.gov/public/do/PRAMain. Find this particular information collection by selecting "Currently under

30-day Review—Open for Public Comments" or by using the search function.

FOR FURTHER INFORMATION CONTACT:

Muntasir Ali, Sector Policies and Program Division (D243-05), Office of Air Quality Planning and Standards, U.S. Environmental Protection Agency, Research Triangle Park, North Carolina, 27711; telephone number: (919) 541-0833; email address: ali.muntasir@ epa.gov.

SUPPLEMENTARY INFORMATION:

Supporting documents, which explain in detail the information that the EPA will be collecting, are available in the public docket for this ICR. The docket can be viewed online at https:// www.regulations.gov, or in person at the EPA Docket Center, WJC West Building, Room 3334, 1301 Constitution Ave. NW, Washington, DC. The telephone number for the Docket Center is 202-566-1744. For additional information about EPA's public docket, visit: http:// www.epa.gov/dockets.

Abstract: The National Emission Standards for Hazardous Air Pollutants (NESHAP) for Semiconductor Manufacturing (40 CFR part 63, subpart BBBBB) were proposed on May 8, 2002; and promulgated on May 22, 2003. These regulations apply to both existing facilities and new facilities that either emits, or has the potential to emit, considering controls, in the aggregate. any single hazardous air pollutants (HAP) at a rate of 10 tons per year (tpy) or more or any combination of HAP at a rate of 25 tpy or more. New facilities include those that either commenced construction, modification, or reconstruction after the date of proposal. This information is being collected to assure compliance with 40 CFR part 63, subpart BBBBB.

Form Numbers: None. Respondents/affected entities: Semiconductor manufacturing facilities. Respondent's obligation to respond: Mandatory (40 CFR part 63, subpart BBBBB).

Estimated number of respondents:

Approximately one (total).

Frequency of response: Semiannually. Total estimated burden: 41 hours (per year). Burden is defined at 5 CFR 1320.3(b).

Total estimated cost: \$5,450 (per year), which includes \$550 in annualized capital/startup and/or operation & maintenance costs.

Changes in the Estimates: There is no change in burden from the mostrecently approved ICR as currently identified in the OMB Inventory of Approved Burdens. This is due to two considerations: (1) The regulations have

¹ City of South Bend, Indiana, 27 FERC ¶ 62,056 (1984). Subsequently, on January 31, 2017, the project was transferred to University of Notre Dame. (P-7569-005)